

**Notice of References Cited**

Application/Control No.

10/509,575

Applicant(s)/Patent Under  
Reexamination  
IIJIMA ET AL.

Examiner

Daniel C. McCracken

Art Unit

1754

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,232,706	05-2001	Dai et al.	313/309
*	B	US-6,420,293	07-2002	Chang et al.	501/95.2
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	T	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Fan, et al., Self-Oriented Regular Arrays of Carbon Nanotubes and Their Field Emission Properties, Science 283 (5401) pp. 512-514 (22 January 1999)
	V	Su, et al., Lattice-Growth of Single-Walled Carbon Nanotubes, J. Phys. Chem. B 104 (28) pp.6505-6508 (2000)
	W	Hongo, et al., Chemical vapor deposition of single-wall carbon nanotubes on iron-film-coated sapphire substrates, Chem. Phys. Ltr. 361 (2002) 349-354
	X	Wu, et al., Carbon Nanowalls Grown by Microwave Plasma Chemical Vapor Deposition, Adv. Mater. 2002, 14, no.1, pp. 64-67 (2002)

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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	P					
	Q					
	R					
	S					
	T					

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*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Stewart, et al., Chemical and Biological Applications of Porous Silicon Technology, Adv. Mater. 2000, 12, No. 12 pp. 859-869
	V	Ward, et al., Substrate effects on the growth of carbon nanotubes by thermal decomposition of methane, Chem. Phys. Ltr. 376 (2003) 717-725.
	W	
	X	

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